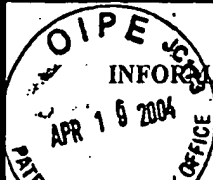


APPLICANT COPY

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|  <p>INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)</p> | Docket Number (Optional) 62478-2100 | Application Number 09/650,029 |
| | Applicant(s) Shinji Kawano | |
| | Filing Date August 28, 2000 | Group Art Unit 2144 |

U.S. PATENT DOCUMENTS

| *EXAMINER INITIAL | REF | DOCUMENT NUMBER | DATE | NAME | CLASS | SUBCLASS | FILING DATE IF APPROPRIATE |
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FOREIGN PATENT DOCUMENTS

| | REF | DOCUMENT NUMBER | DATE | COUNTRY | CLASS | SUBCLASS | Translation | |
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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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| LP | | [Partial English Translation] for "Notification of Reasons for Refusal," issued on March 2, 2004 for corresponding Japanese Application No. 2000-273912, pages 1-6. |
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| EXAMINER  | DATE CONSIDERED 04/11/05 |
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.